



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Cathie J. BURKE et al.

Application No.: 10/046,245

Group Art Unit: 1756

Filed: January 16, 2002

Docket No.: 106452

For: METHODS OF PATTERNING RESISTS AND STRUCTURES INCLUDING THE  
PATTERNED RESISTS

**REQUEST FOR APPROVAL OF DRAWING CORRECTIONS**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed corrections to  
Figures 3-6, marked in red on the attached copy of such drawing figures.

Upon approval by the Examiner, and upon allowance of this application, the  
formal drawings will be corrected.

Respectfully submitted,

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**RECEIVED**  
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**TC 1700**

JAO:JAD/ldg

Date: April 10, 2002

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